



6-14-01

04400
PATENT

Case Docket No. ASMEX.282A

Date: June 28, 2001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2

Applicant(s) : Zhimin Lu
Appl. No. : 09/870,393
Filed : May 29, 2001
For : METHOD AND
APPARATUS TO CORRECT
WAFER DRIFT

Group Art Unit : Unknown
Batch No. : Unknown
Examiner : Unknown

I hereby certify that this correspondence
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Patents, Washington, D.C. 20231, on

June 28, 2001

(Date)

Adeel S. Akhtar, Reg. No. 41,394

TRANSMITTAL LETTER

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

ATTENTION: OFFICIAL DRAFTSPERSON

Dear Sir:

Enclosed for filing are Twelve (12) sheets of formal drawings:

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit
any overpayment, to Account No. 11-1410; and

(X) A return prepaid postcard.

Adeel S. Akhtar
Registration No. 41,394
Attorney of Record

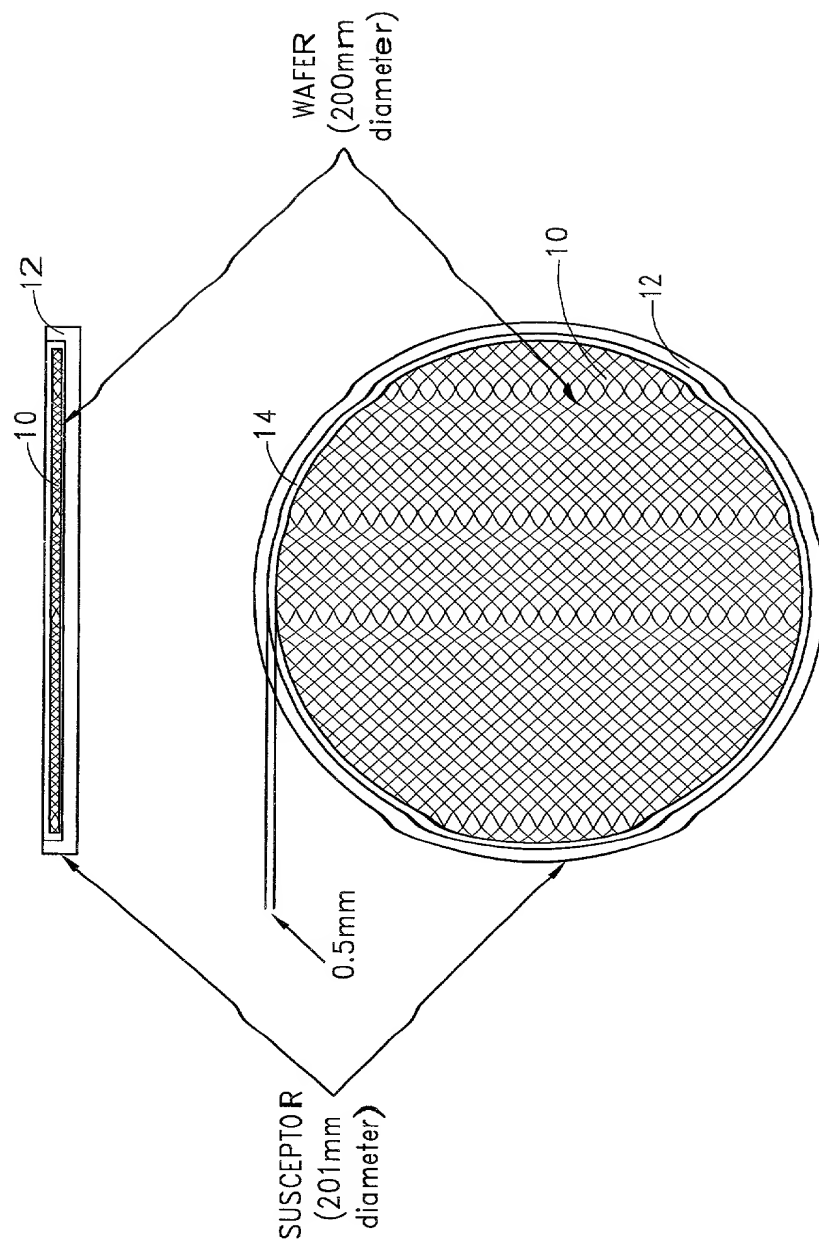


FIG. 1

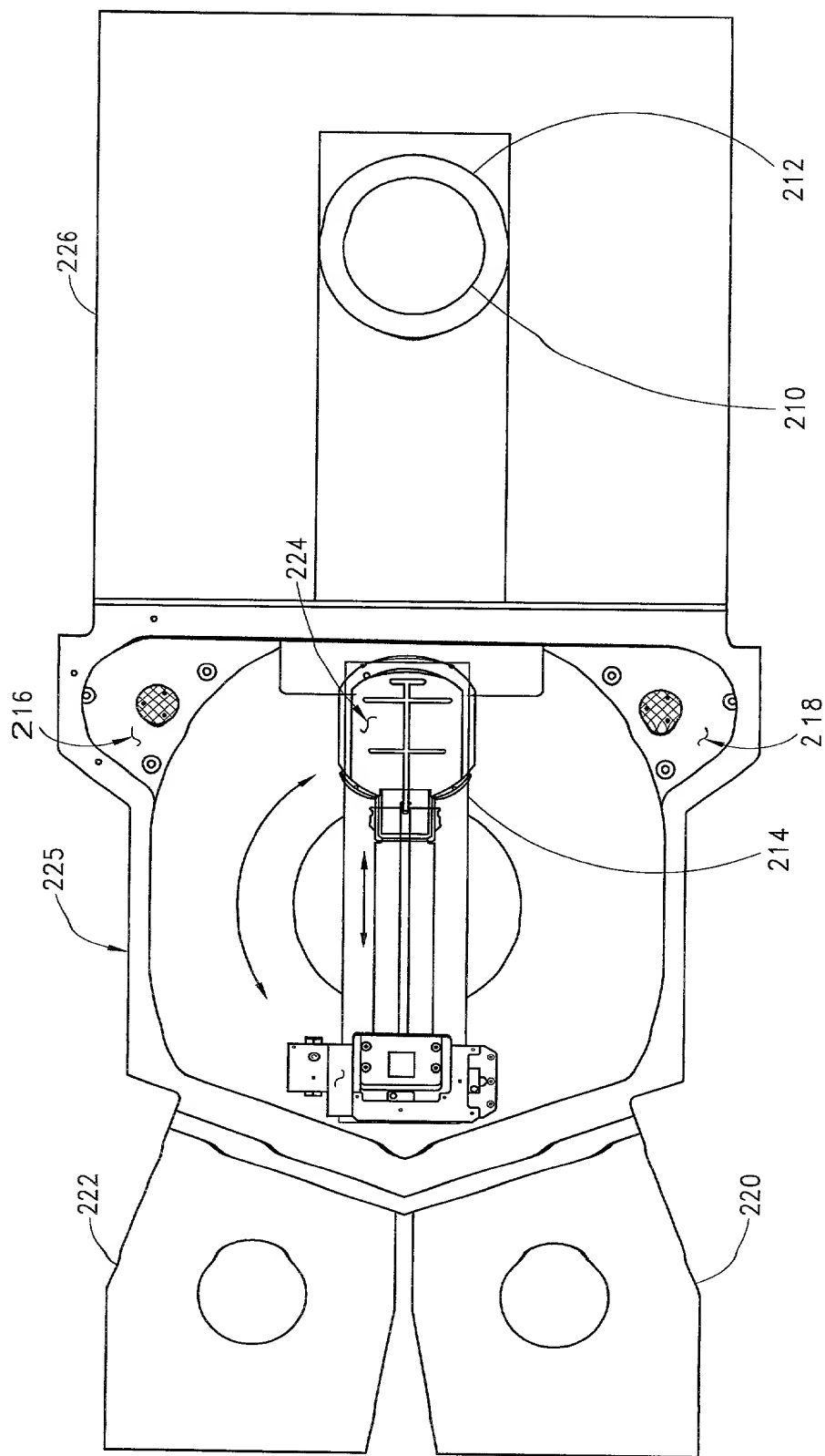


FIG. 2A

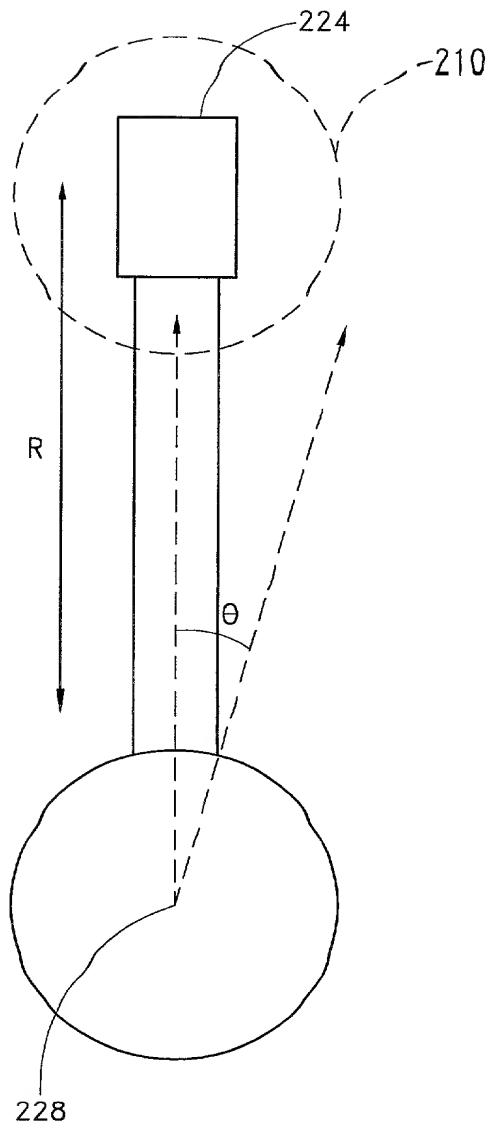


FIG. 2B

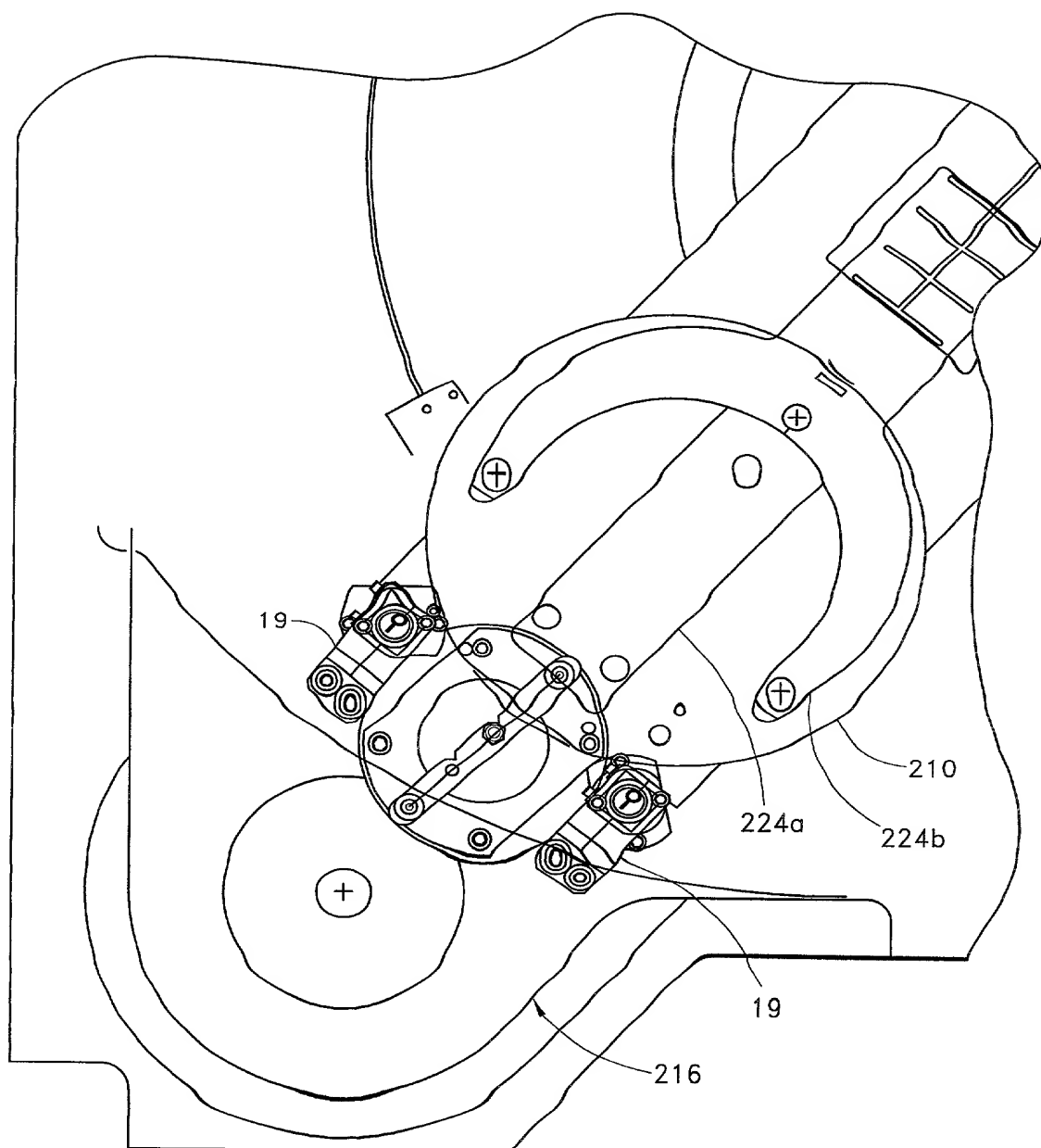


FIG. 2C

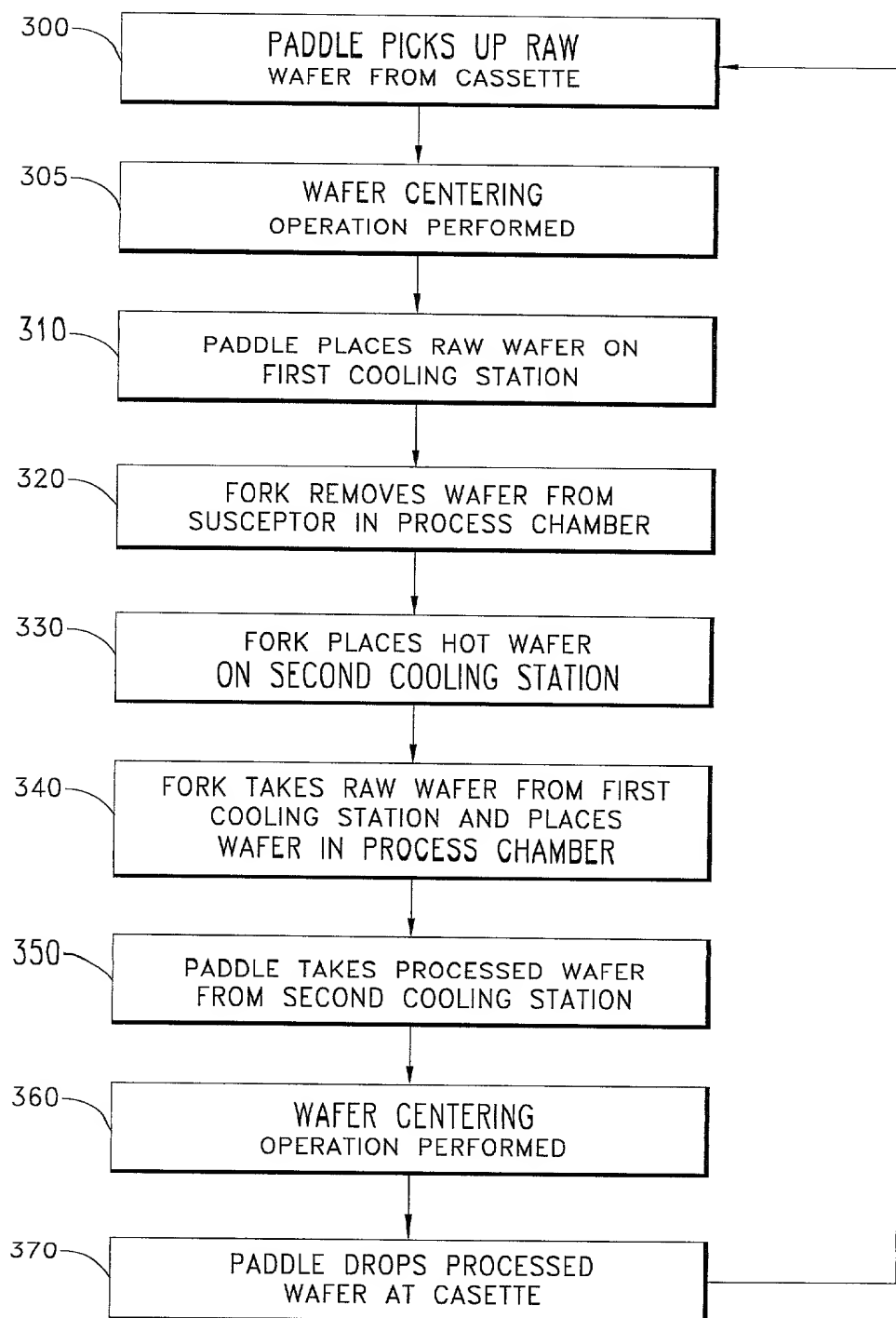


FIG. 3

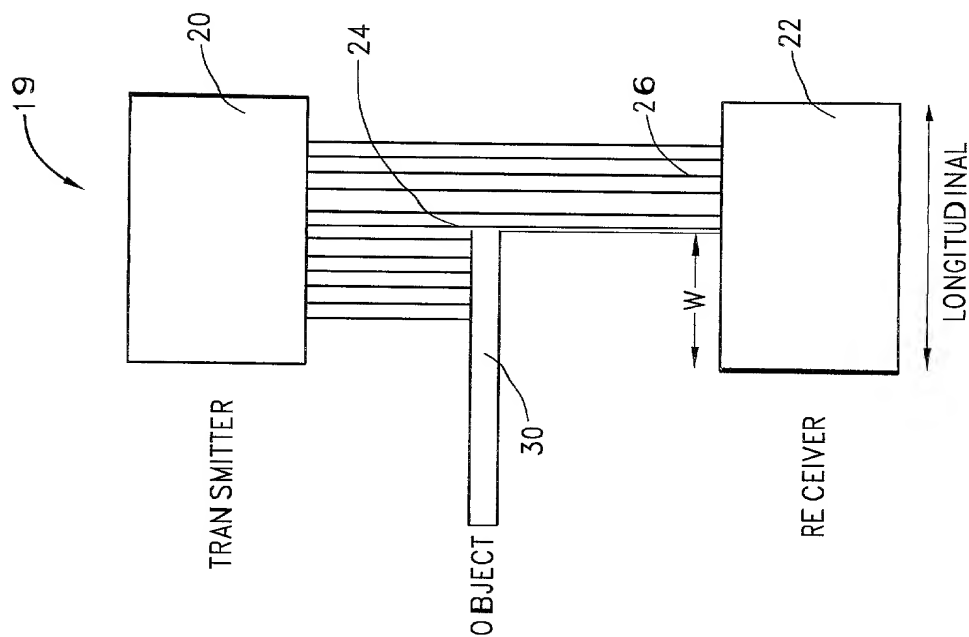


FIG. 4

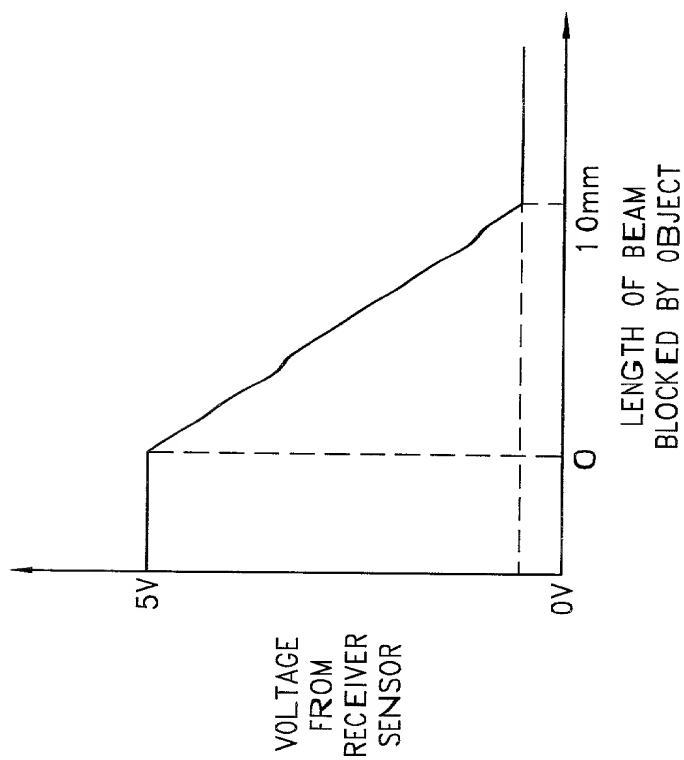
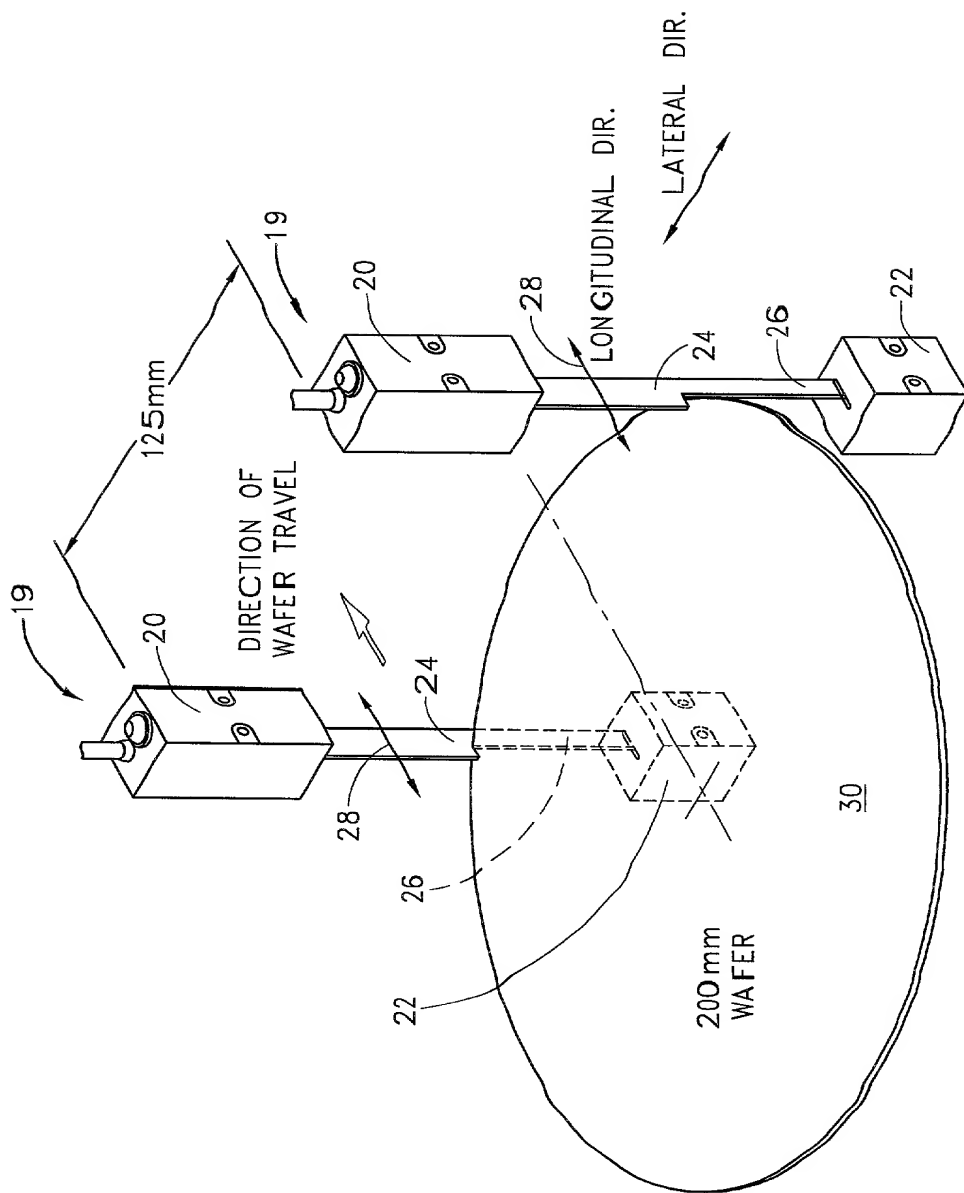


FIG. 5



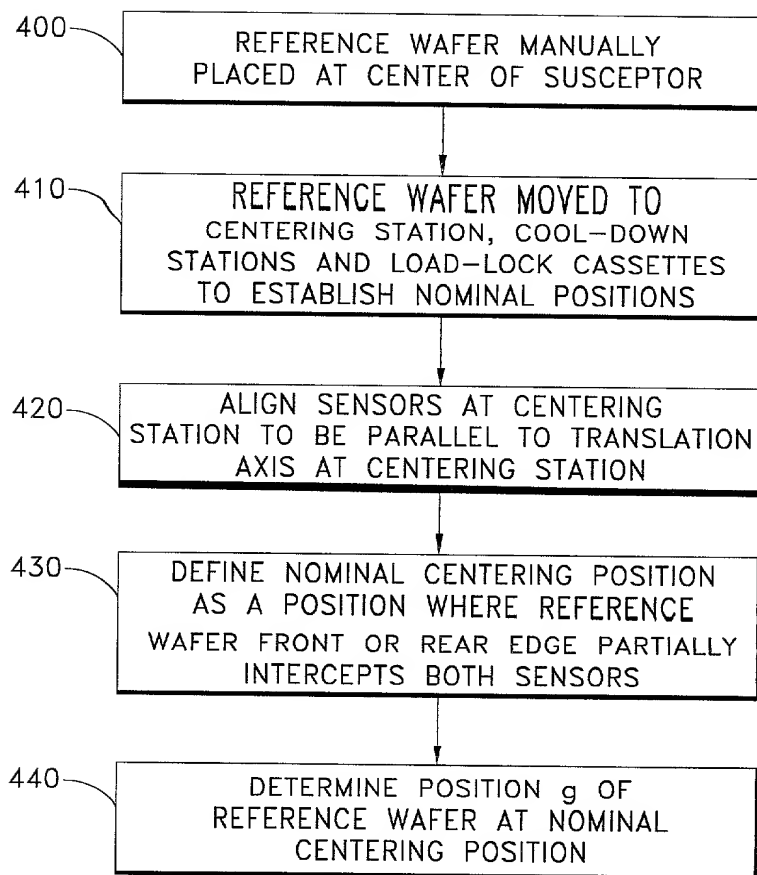


FIG. 7

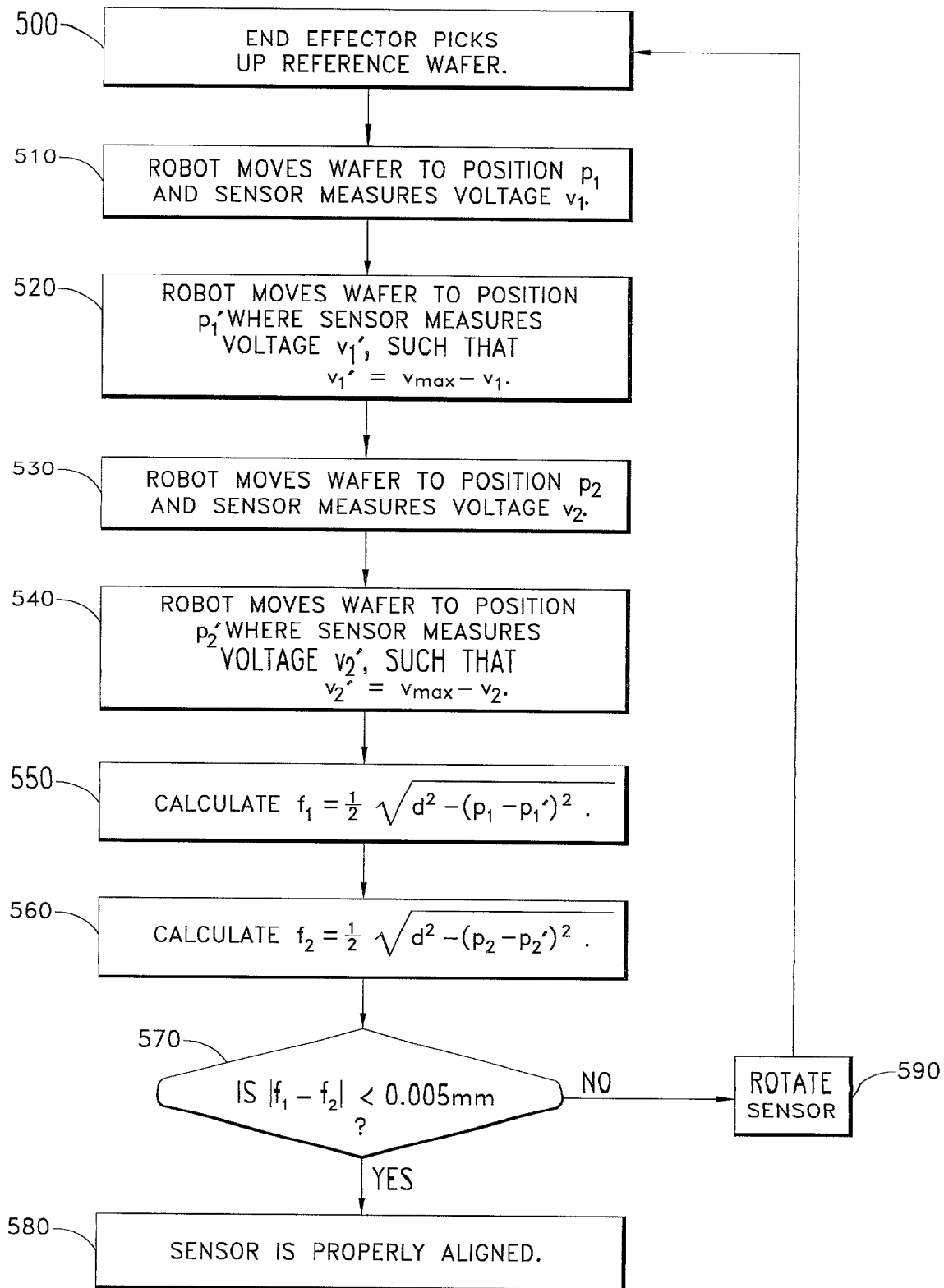


FIG. 8

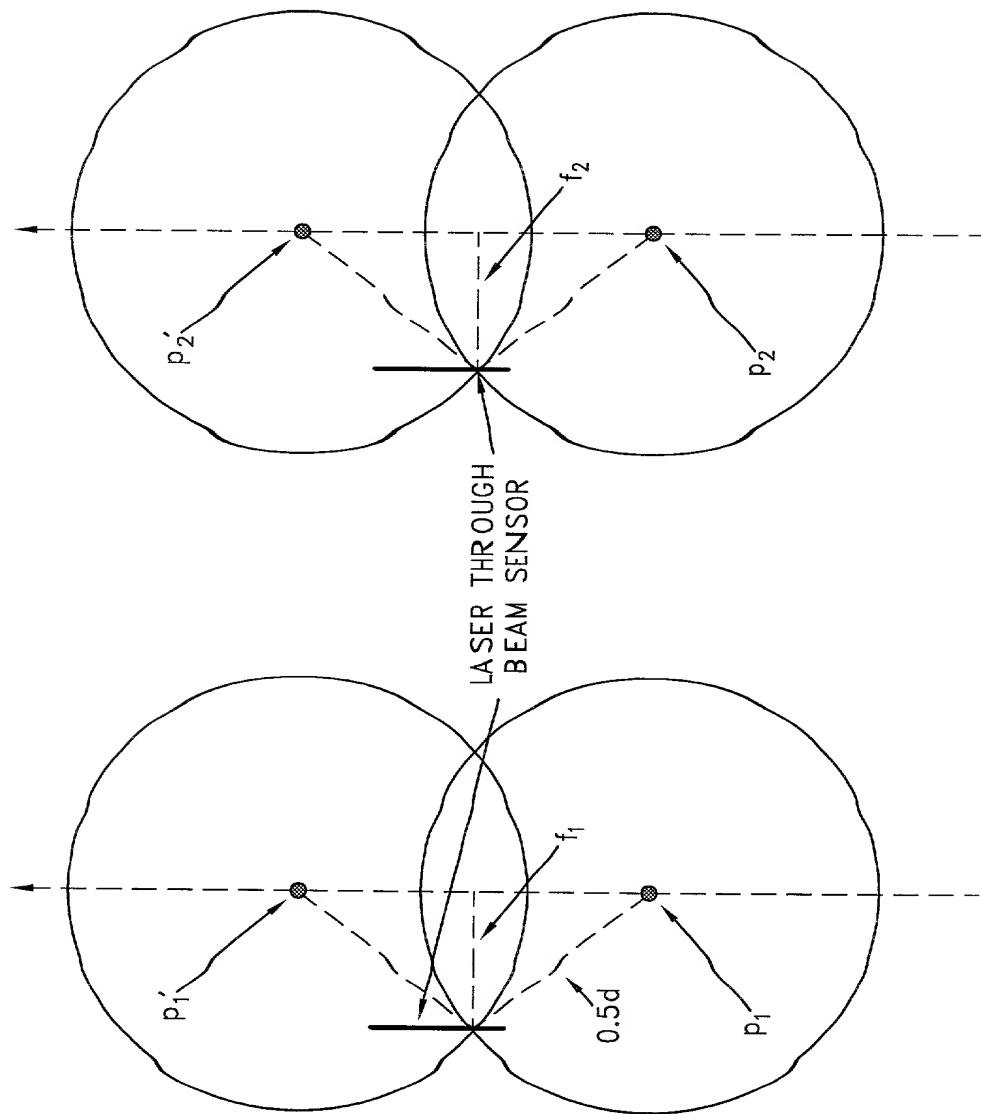


FIG. 9

FIG. 10

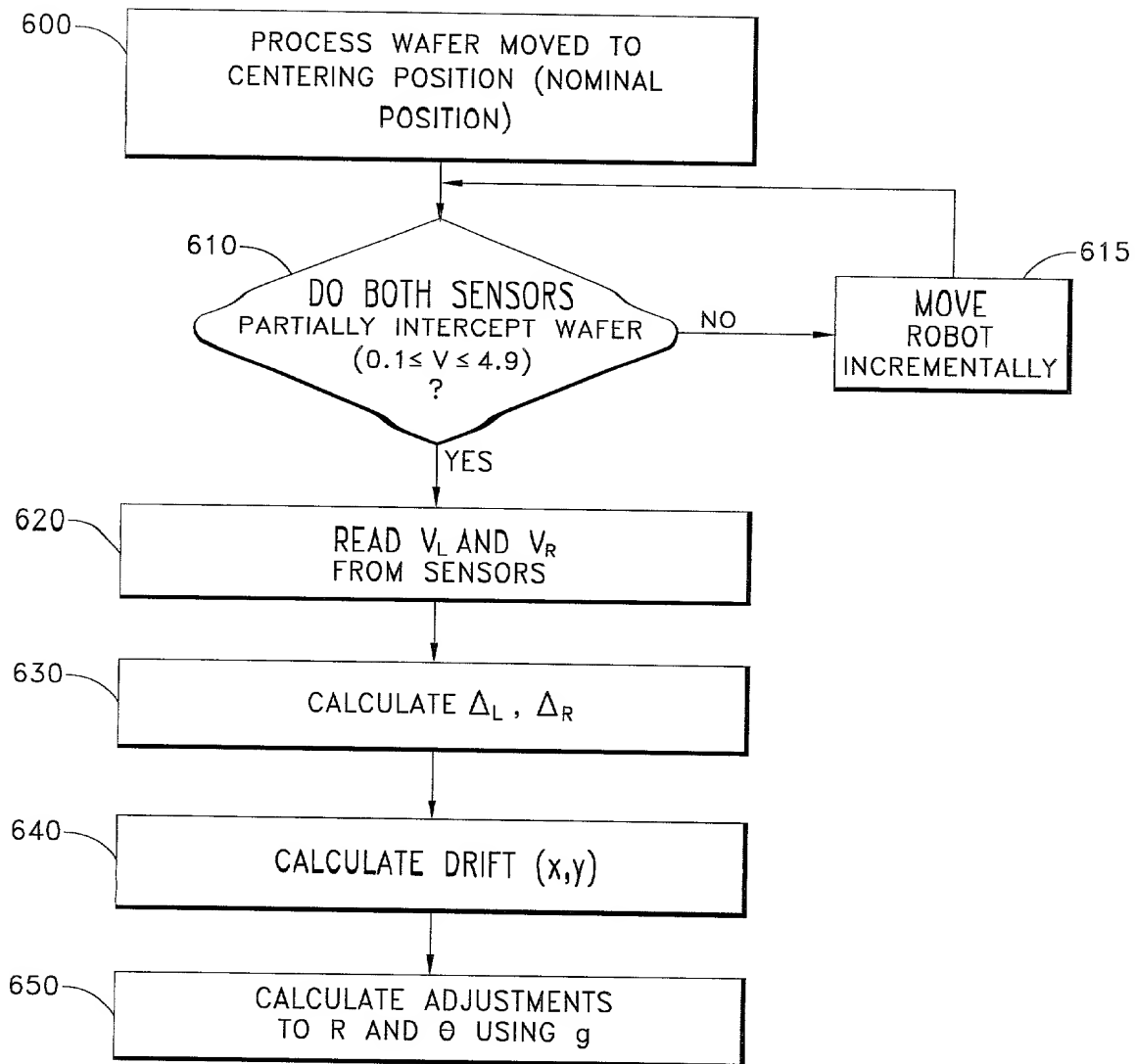


FIG. 11

WAFER POSITION/ERROR CALCULATION

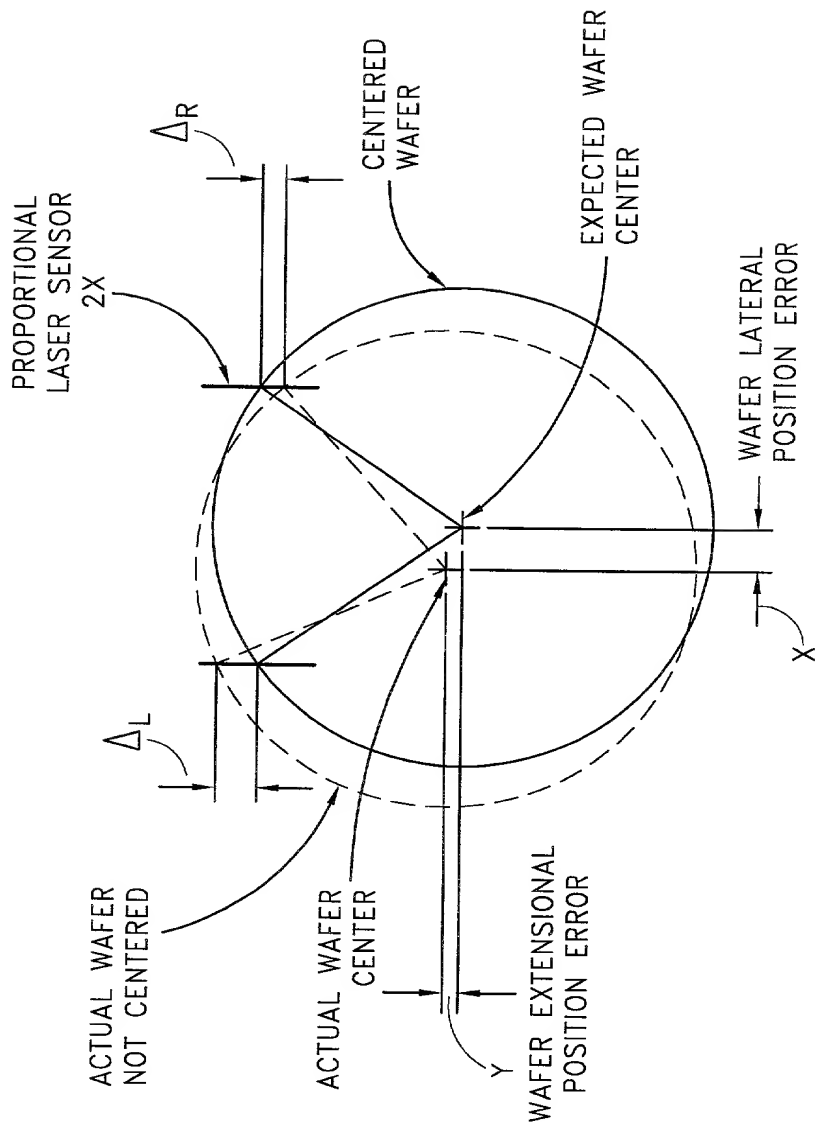


FIG. 12